I hereby certify that this correspondence is being deposited with the United States Postal Service, with sufficient postage, as first class mail in an envelope addressed to:

Commissioner for Patents
Washington, D.C. 20231
on November 14, 2002

Date of Deposit

Anastasia Heffner

Name of applicant, assignee or Registered Representative

Signature

Signature

Date of Signature

#7 | Amend SNT | B.

## **RECEIVED**

NOV 2 1 2002

**TECHNOLOGY CENTER R3700** 

Our Case No. 7103/261 (P0704)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ln re	Application of:	)
Radman		)
Serial No. 09/843,323		) Examiner: M. Rachuba
Filing Date: April 25, 2001		) Group Art Unit No. 3723
For ·	SPHERICAL CAP-SHAPED POLISHING HEAD IN A CHEMICAL MECHANICAL POLISHING APPARTUS FOR	) ) ) )
	SEMICONDUCTOR WAFERS	,

## **AMENDMENT**

Commissioner for Patents Washington, D.C. 20231

Dear Sir:

In response to the Office Action dated August 14, 2002, please enter the following amendment and consider the following remarks:

11/20/2002 MAHMED1 00000047 09843323

IN THE CLAIMS

01 FC:1201

84.00 OP

Please amend claims 1, 9 and 19 to read as follows: